

AF 12811

Docket No.: 50432-067



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kai YANG, et al.

Serial No.: 09/817,056

Filed: March 27, 2001

For: STABILIZING FLUORINE ETCHING OF LOW-K MATERIALS

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Group Art Unit: 2811

Examiner: T. NGUYEN

PATENT

#14 / (NE)  
5/28/3  
Sunder 6

Entered  
6/24/03  
Museum

AMENDMENT UNDER 37 CFR §1.116

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated March 24, 2003, pursuant to the provisions of 37 C.F.R. 1.116.

The claims are presented in the revised amendment format described in the Pre-OG Notice dated January 31, 2003, regarding waiver of the current provisions of 37 C.F.R. §§1.121(a)-1.121(d). Please amend the above-identified application as follows.